

Physics of Electronics:

5. Semiconductors

July – December 2009

Contents overview

- Compensation doping.
- Electrical conduction in semiconductors.
- Continuity equation.
- Semiconductor measurements.

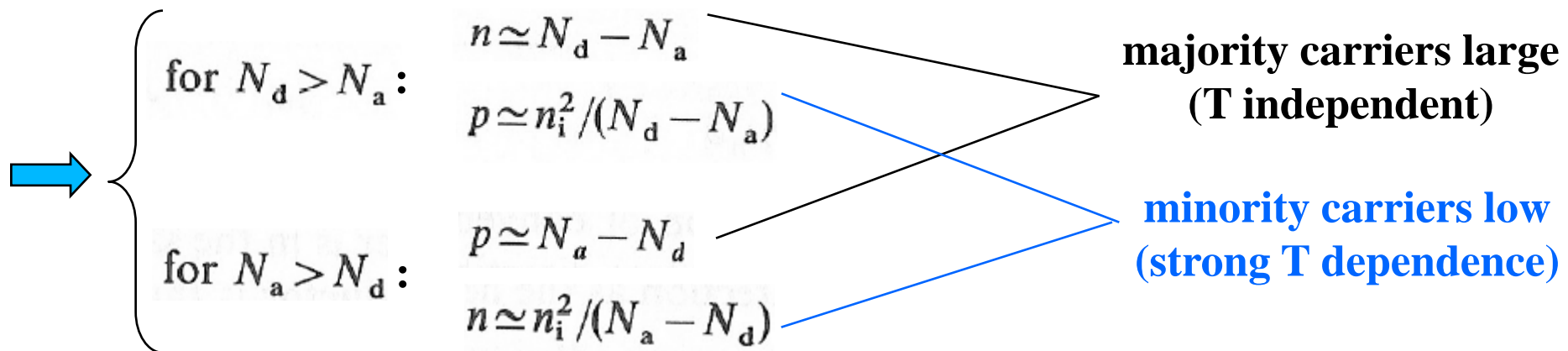
Compensation doping

- Consider a sC with both donors and acceptors
 - Suppose all impurities are ionized ($N_a = N_a^+$ & $N_d = N_d^+$)

$$n + N_a = p + N_d \quad \xrightarrow{np = n_i^2} \quad n^2 - (N_d - N_a)n - n_i^2 = 0 \quad \rightarrow$$

$$n = \frac{N_d - N_a}{2} + \frac{N_d - N_a}{2} \left[1 + \left(\frac{2n_i}{N_d - N_a} \right)^2 \right]^{1/2} \quad p = \frac{N_a - N_d}{2} + \frac{N_d - N_a}{2} \left[1 + \left(\frac{2n_i}{N_d - N_a} \right)^2 \right]^{1/2}$$

- Extrinsic compensated $n_i \ll |N_d - N_a|$



Electrical conduction in sC.

- Conductivity (response to an electric field)
 - In a sC we have e^- 's and h^+ 's moving:

$$\begin{array}{l} J_e = ne\mu_e \mathcal{E} \\ J_h = pe\mu_h \mathcal{E} \end{array} \quad \longrightarrow \quad J = J_e + J_h = e(n\mu_e + p\mu_h)\mathcal{E}$$

σ

- In a n-type sC ($n \gg p$):

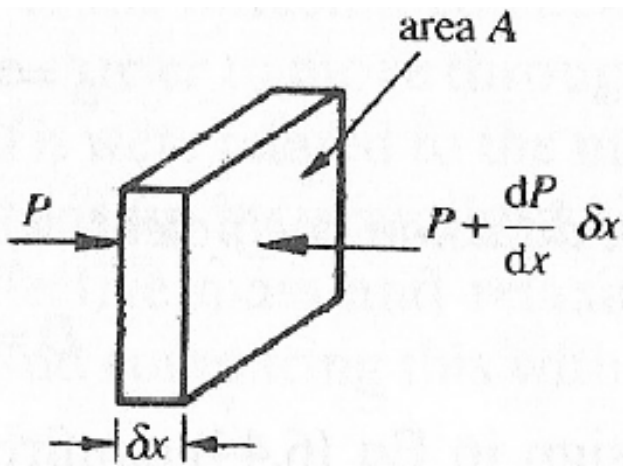
$$\sigma_n \simeq en\mu_e \simeq eN_d\mu_e$$

- In a p-type sC ($p \gg n$):

$$\sigma_p \simeq ep\mu_h \simeq eN_a\mu_h$$

Electrical conduction in sC.

- Diffusion of charge carriers
 - Diffusion occurs when concentration gradients are present.
 - In a **neutral gas** with gradient in the x direction:



Overall force on the elemental volume

$$\left[P(x) - \left(P + \frac{dP}{dx} \delta x \right) \right] A = -\frac{dP}{dx} \delta x A$$

Average force on each particle

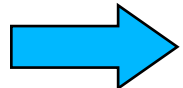
$$F_D = -\frac{1}{N} \frac{dP}{dx}$$

Electrical conduction in sC.

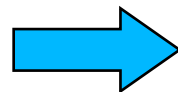
- Diffusion of charge carriers
 - Diffusion occurs when concentration gradients are present.
 - In a **neutral gas** with gradient in the x direction:
 - v_D due to an external force (see calculations in Chap 4):

$$v_D = F \tau_r / m$$

- v_D due to F_D :


$$v_D = -\frac{\tau_r}{M} \frac{1}{N} \frac{dP}{dx}$$

$$P = N k T$$



$$v_D = \frac{\overbrace{\tau_r k T}^D}{M} \frac{1}{N} \frac{dN}{dx}$$

Electrical conduction in sC.

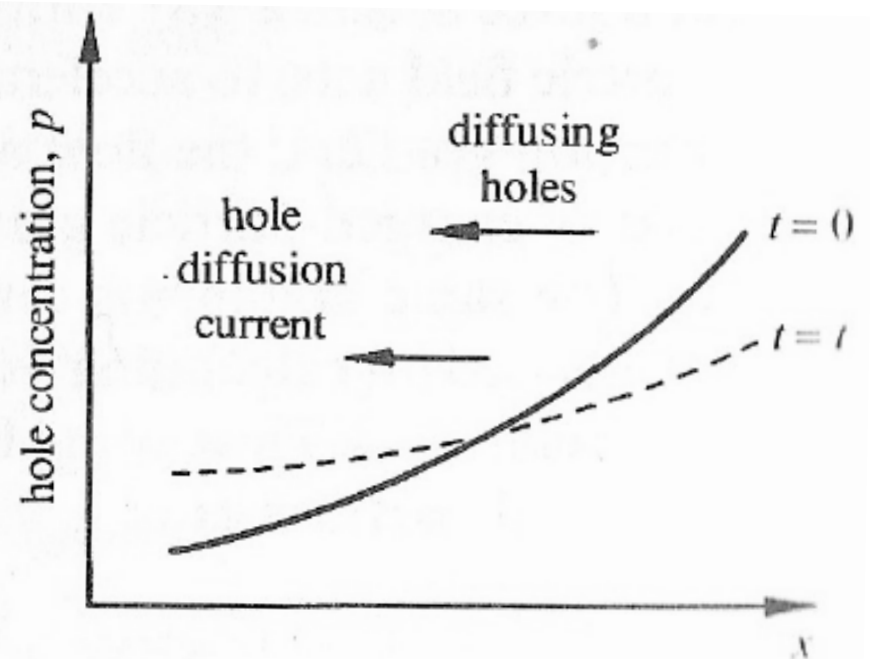
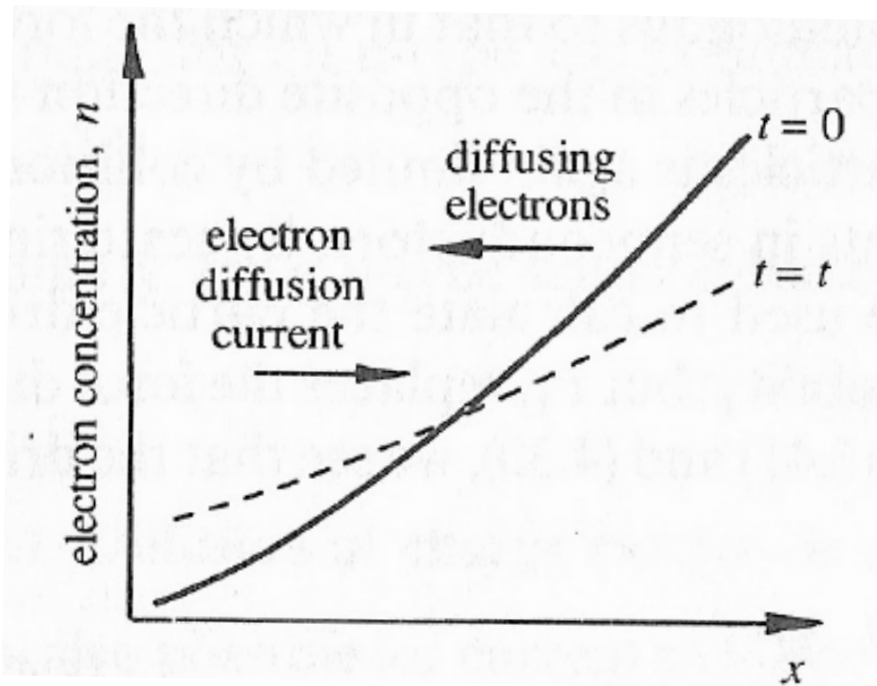
- Diffusion of charge carriers
 - In a sC with a concentration gradient of the e^- and h^+ :

$$v_{De} = -D_e \frac{1}{n} \frac{dn}{dx}$$

$$v_{Dh} = -D_h \frac{1}{p} \frac{dp}{dx}$$

➡ $J_{De} = -nev_D = eD_e \frac{dn}{dx}$

➡ $J_{Dh} = -eD_h \frac{dp}{dx}$



Electrical conduction in sC.

- Diffusion of charge carriers
 - Diffusion coefficient is related with mobility:

$$D = \frac{\tau_r kT}{M} \quad \mu = e\tau_r/m \quad D_e = (kT/e)\mu_e \quad \rightarrow \quad D_e/\mu_e = D_h/\mu_h = kT/e$$

- Total current flow

$$J_e = ne\mu_e \mathcal{E} + eD_e \nabla n$$

$$J_h = pe\mu_h \mathcal{E} - eD_h \nabla p$$

response to
electrical field

diffusion

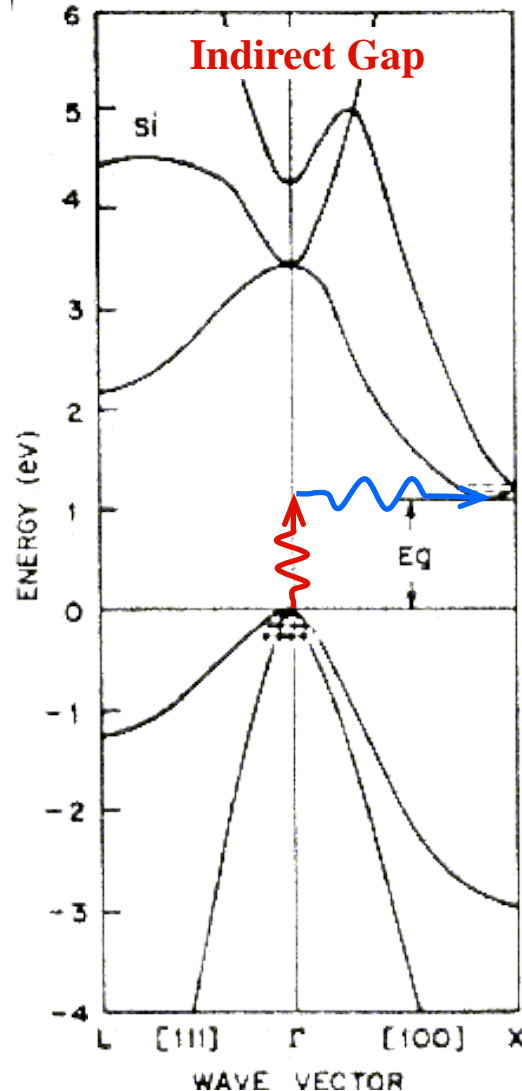
$$J_h = 0$$

$$\mathcal{E} = \frac{D_h \nabla p}{p \mu_h}$$

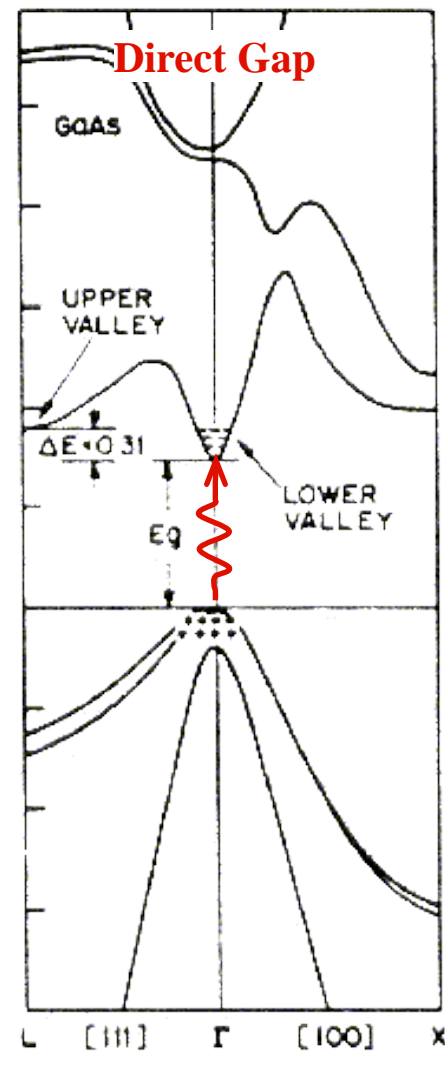
current can be compensated
at a particular electrical
field

Electron Processes in Real sC

- Direct and indirect gap sC



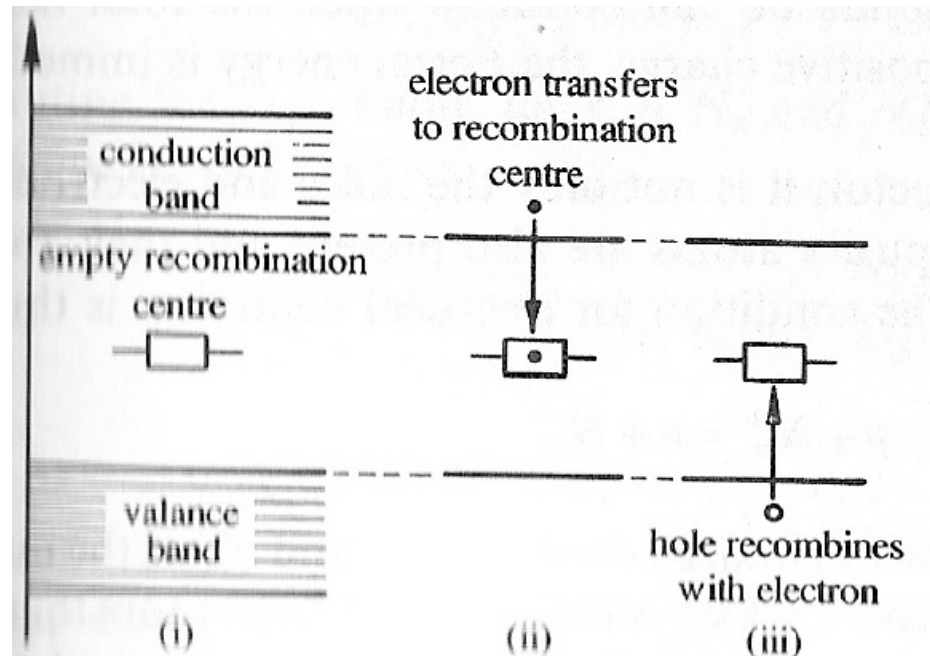
The minimum separation cannot be reached optically.



The minimum separation can be reached optically (by means of a photon).

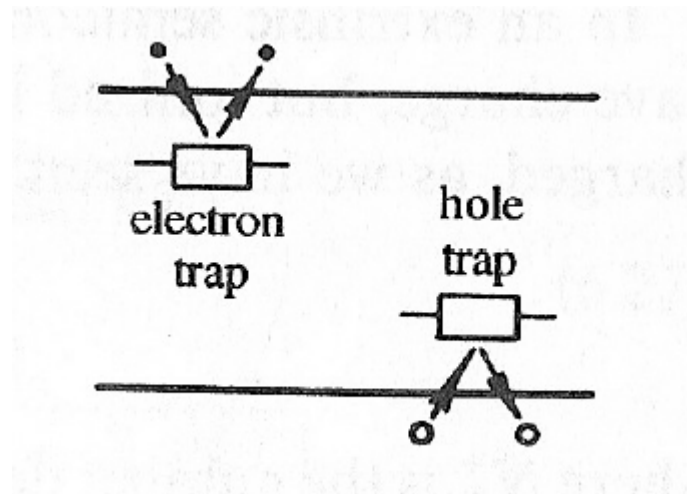
Electron Processes in Real sC

- Recombination
 - Permanent loss of a carrier.
 - Due to conservation of momentum
 - Possible in direct-gap sC's.
 - Marginally probable in indirect-gap sC's. Intermediate steps are required.



Electron Processes in Real sC

- Trapping
 - Temporary removal of a carrier on localized states



- Localized states
 - Lattice defects (dislocations, vacancies).
 - Impurities.

Continuity Equation for Minority Carriers

- General considerations:
 - Describes how charge density varies in time.
 - Two main causes for the variation:
 - Rate of generation and loss
 - Drift of carriers
- I.CASE: No current flow (no gradient & no \mathcal{E})
 - Let's consider a **p-type** material:

$$\frac{dn}{dt} = G - R$$

Variation = Generation – Recombination

In this case, only
 T dependent

$$R = r n(t) p(t)$$

Continuity Equation for Minority Carriers

- I.CASE: No current flow (no gradient & no \mathcal{E})

- Consider first equilibrium:

$$dn/dt=0 \quad \Rightarrow \quad G(T)=rn_0p_0=rn_i^2$$

- Now consider variations from the equilibrium:

$$n = n_0 + \delta n \quad \longleftrightarrow \quad p = p_0 + \delta p \quad \text{with } \delta n = \delta p \quad \leftarrow \text{To maintain charge neutrality}$$

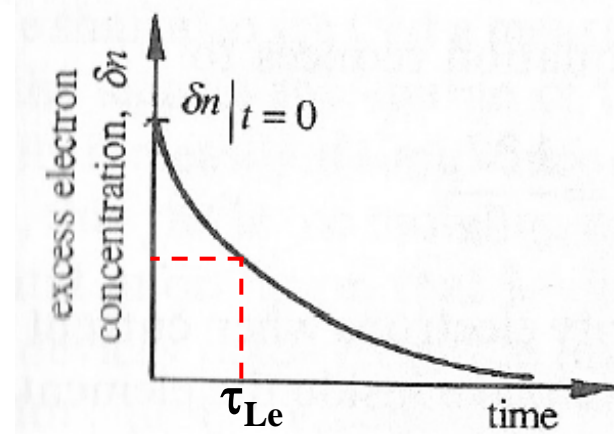
$$\Rightarrow \quad (dn/dt)|_{J=0} = [d(\delta n)/dt]|_{J=0} = G(T) - r(n_0 + \delta n)(p_0 + \delta p)$$

$$\Rightarrow \quad [d(\delta n)/dt]|_{J=0} = -r\overset{p_0 \gg n_0}{n_0}\delta p - rp_0\delta n - r\cancel{\delta n\delta p}^0 \quad \leftarrow \text{Considering } T=\text{const.}$$

$$\Rightarrow \quad [d(\delta n)/dt]|_{J=0} = -rp_0\delta n = -\delta n/\tau_{Le}$$

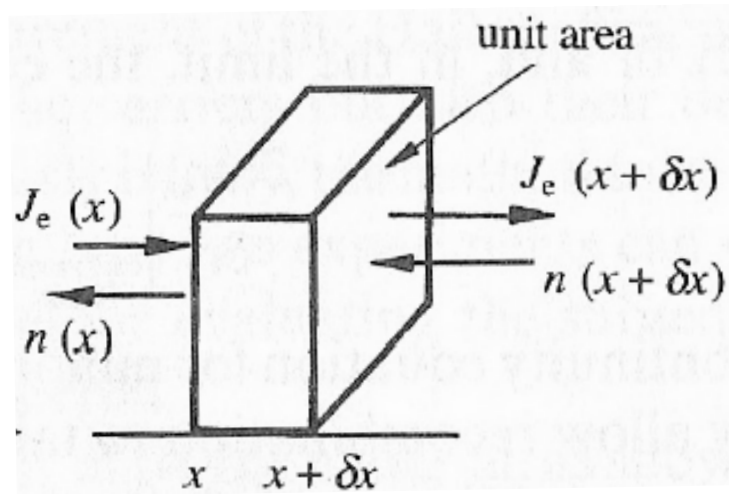
- For a **n-type** material:

$$d(\delta p)/dt = -\delta p/\tau_{Lh}$$



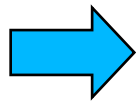
Continuity Equation for Minority Carriers

- II.CASE: With current flow

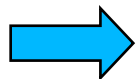


$$J_e = -nev_D$$

$$\begin{cases} n_{x+\delta x} = J_e(x + \delta x)/ev_D \\ n_x = J_e(x)/ev_D \end{cases}$$

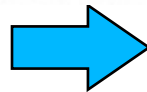


$$\begin{aligned} n_{x+\delta x} - n_x &= \delta n = [J_e(x + \delta x) - J_e(x)]/ev_D \\ &= \frac{1}{ev_D} \left(J_e(x) + \frac{\partial J_e}{\partial x} \delta x - J_e(x) \right) \end{aligned}$$



$$\delta n = \frac{1}{ev_D} \frac{\partial J_e}{\partial x} \delta x$$

$$v_D = \partial x / \partial t$$



$$\left. \frac{\partial(\delta n)}{\partial t} \right|_{\text{current flow}} = \frac{1}{e} \frac{\partial J_e}{\partial x}$$

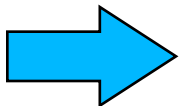
Continuity Equation for Minority Carriers

- Total continuity equation

$$\left. \frac{\partial(\delta n)}{\partial t} \right|_{\text{total}} = -\frac{\delta n}{\tau_{Le}} + \frac{1}{e} \frac{\partial J_e}{\partial x}$$

But $J_e = ne\mu_e \mathcal{E} + eD_e \nabla n$

$$n = n_0 + \delta n$$

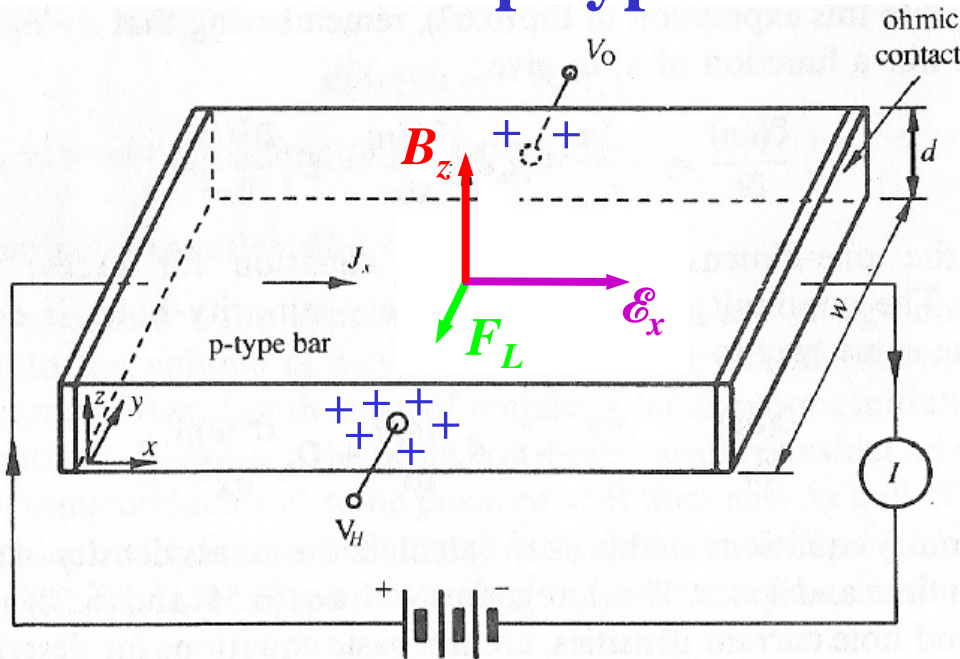


$$\frac{\partial(\delta n)}{\partial t} = -\frac{\delta n}{\tau_{Le}} + \mu_e \mathcal{E}_x \frac{\partial(\delta n)}{\partial x} + D_e \frac{\partial^2(\delta n)}{\partial x^2}$$

(idem for holes in an n-type material)

Semiconductor Measurements

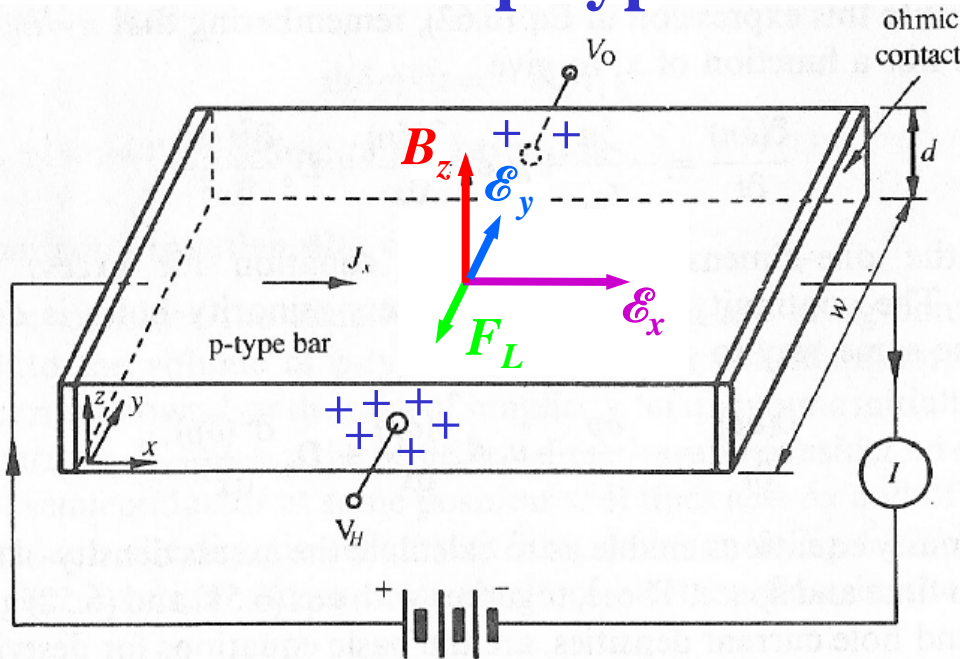
- Hall effect
 - Consider **p-type** material



$$F_L = ev \times B \Rightarrow |F_L| = e v_{Dx} B_z$$

Semiconductor Measurements

- Hall effect
 - Consider **p-type** material

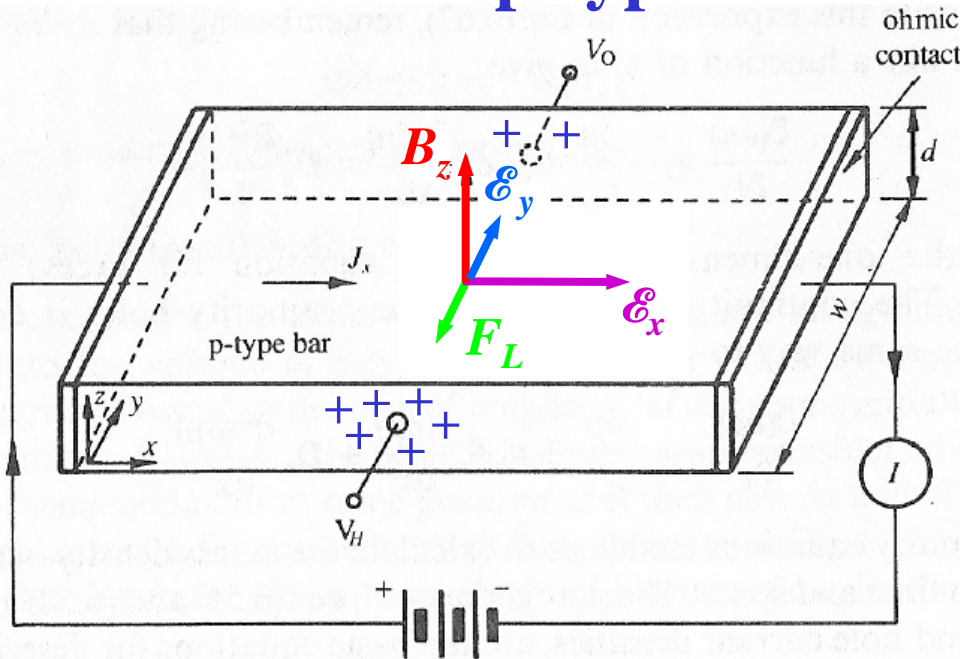


$$F_L = ev \times B \Rightarrow |F_L| = e v_{Dx} B_z$$

$$\Rightarrow e\mathcal{E}_y = F_L = ev_{Dx} B_z$$

Semiconductor Measurements

- Hall effect
 - Consider **p-type** material



$$F_L = ev \times B \Rightarrow |F_L| = e v_{Dx} B_z$$

$$\Rightarrow \left. \begin{aligned} e\mathcal{E}_y &= F_L = ev_{Dx} B_z \\ \& \quad J_x \simeq pev_{Dx} \end{aligned} \right\} \mathcal{E}_y = J_x B_z / pe$$

The Hall coefficient is defined:

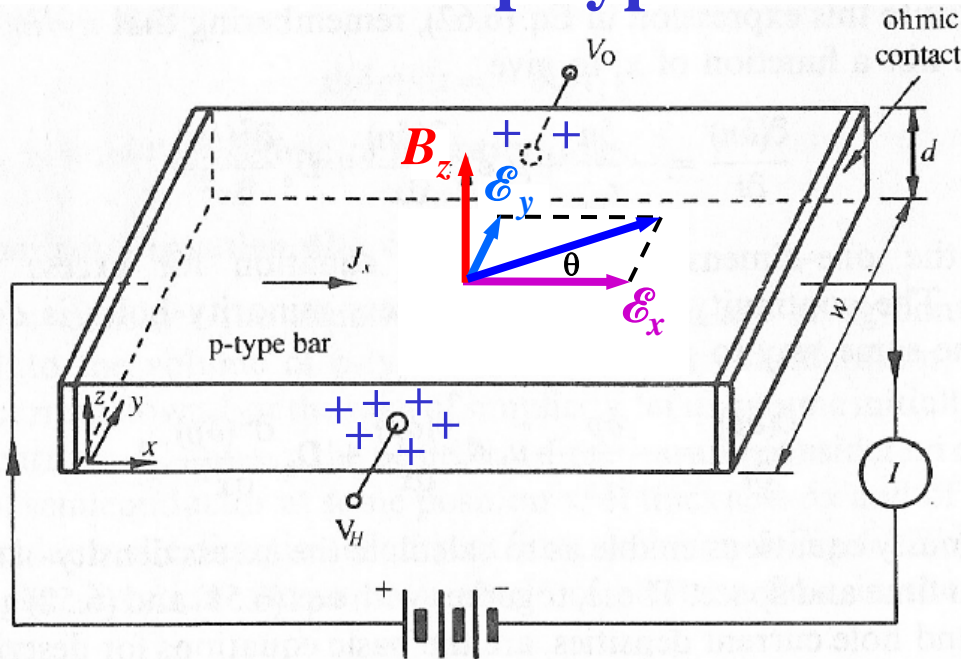
$$R_H = \mathcal{E}_y / J_x B_z = 1/pe$$

- If V_H and I are measured:

$$\left. \begin{aligned} V_H &= \mathcal{E}_y w \\ I &= J_x w d \end{aligned} \right\} R_H = \frac{V_H}{w I B_z} w d = \frac{V_H d}{I B_z} = \frac{1}{pe}$$

Semiconductor Measurements

- Hall effect
 - Consider **p-type** material



The Hall angle is defined:

$$\tan \theta = \mathcal{E}_y / \mathcal{E}_x$$

$$\Rightarrow \tan \theta = \frac{J_x B_z}{pe} \frac{\sigma}{J_x} = \mu_h B_z$$

$$\Rightarrow \mu_h = R_H \sigma$$

- For a **n-type** material:

$$R_{He} = -1/ne$$

Semiconductor Measurements

- Hall effect

- Consider both type of carriers to be present:

$$\begin{array}{l} v_{Dh} = \mu_H \mathcal{E}_x \\ v_{De} = -\mu_H \mathcal{E}_x \end{array} \quad \Rightarrow \quad \begin{array}{l} F_h = -e(v_{Dh} \times B) = -ev_{Dh} B_z \\ F_e = e(v_{De} \times B) = -ev_{De} B_z \end{array}$$

- A net current is created in the y direction

$$\sigma \mathcal{E}_y = e(pv_{yh} - nv_{ye})$$

- Now, using the expressions for the Hall angle

$$v_{yh} = \mu_h \mathcal{E}_y = \mu_h (\mathcal{E}_x \tan \theta) = \mu_h (\mathcal{E}_x \mu_h B_z) \quad \& \quad v_{ye} = \mu_e^2 \mathcal{E}_x B_z$$

$$\Rightarrow \sigma \mathcal{E}_y = e(p\mu_h^2 - n\mu_e^2) \mathcal{E}_x B_z$$

- Hall coefficient

$$R_H = \frac{\mathcal{E}_y}{J_x B_z} = \frac{e(p\mu_h^2 - n\mu_e^2)}{\sigma^2}$$

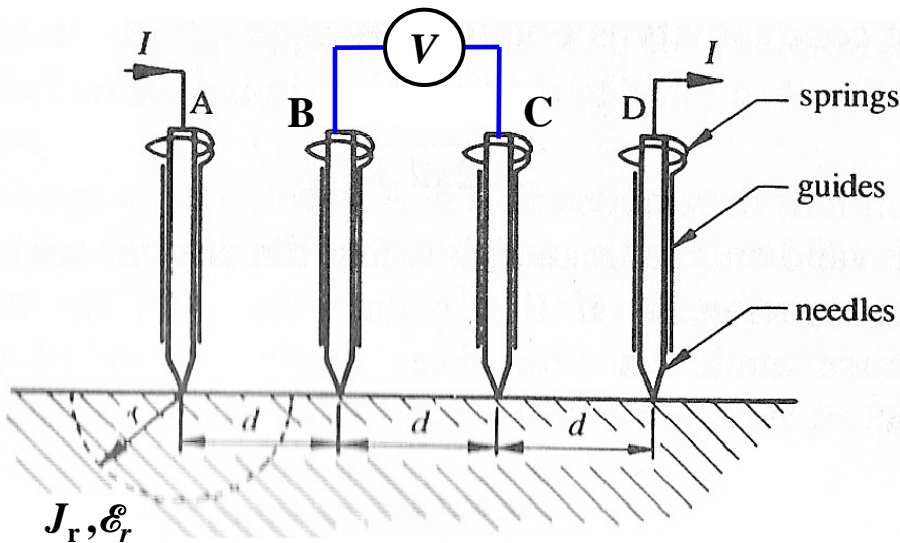
$$\sigma = e(n\mu_e + p\mu_h)$$



$$R_H = \frac{p\mu_h^2 - n\mu_e^2}{e(p\mu_h + n\mu_e)^2}$$

Semiconductor Measurements

- Four-point probe method for conductivity meas.
 - Consider $d \ll L$



For the current leaving A:

$$J_r = I / (2\pi r^2) \Rightarrow \mathcal{E}_r = J / \sigma = I / (2\pi \sigma r^2)$$

Potential at a distance a from A:

$$V_a = \int_{-\infty}^a \mathcal{E}_r dr = -\frac{I}{2\pi\sigma} \int_{-\infty}^a \frac{1}{r^2} dr = \frac{I}{2\pi\sigma a}$$

$$\Rightarrow V_{BC} = \frac{I}{2\pi\sigma d} - \frac{I}{2\pi\sigma(2d)} = \frac{I}{4\pi\sigma d}$$

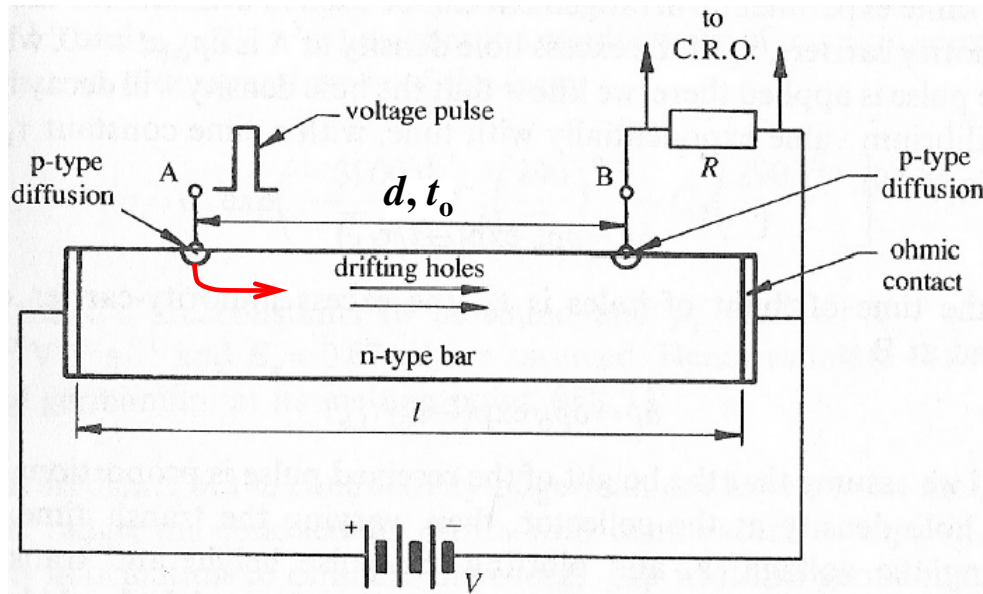
Identically for the current entering D, then:

$$V = 2V_{BC} = \frac{I}{(2\pi\sigma d)}$$

$$\Rightarrow \sigma = \frac{1}{2\pi d} \frac{I}{V}$$

Semiconductor Measurements

- Minority carrier life-time and mobility.



Mobility:

$$v_D = d/t_0 \Rightarrow \mu E = \mu V/l = d/t_0$$

$$\Rightarrow \boxed{\mu = ld/t_0 V}$$

Life-time:

$$d(\delta p)/dt = -\delta p/\tau_{Lh} \Rightarrow \delta p = \delta p_0 \exp(-t/\tau_{Lh})$$

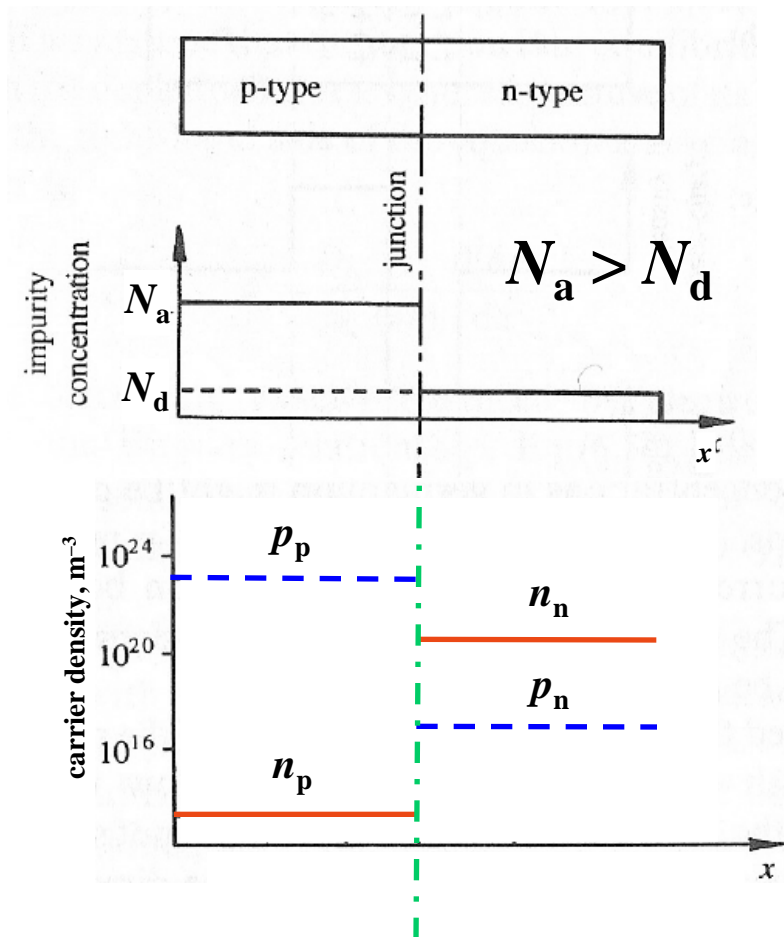
Physics of Electronics:

6. Junction Diodes

July – December 2009

Pn junction in equilibrium

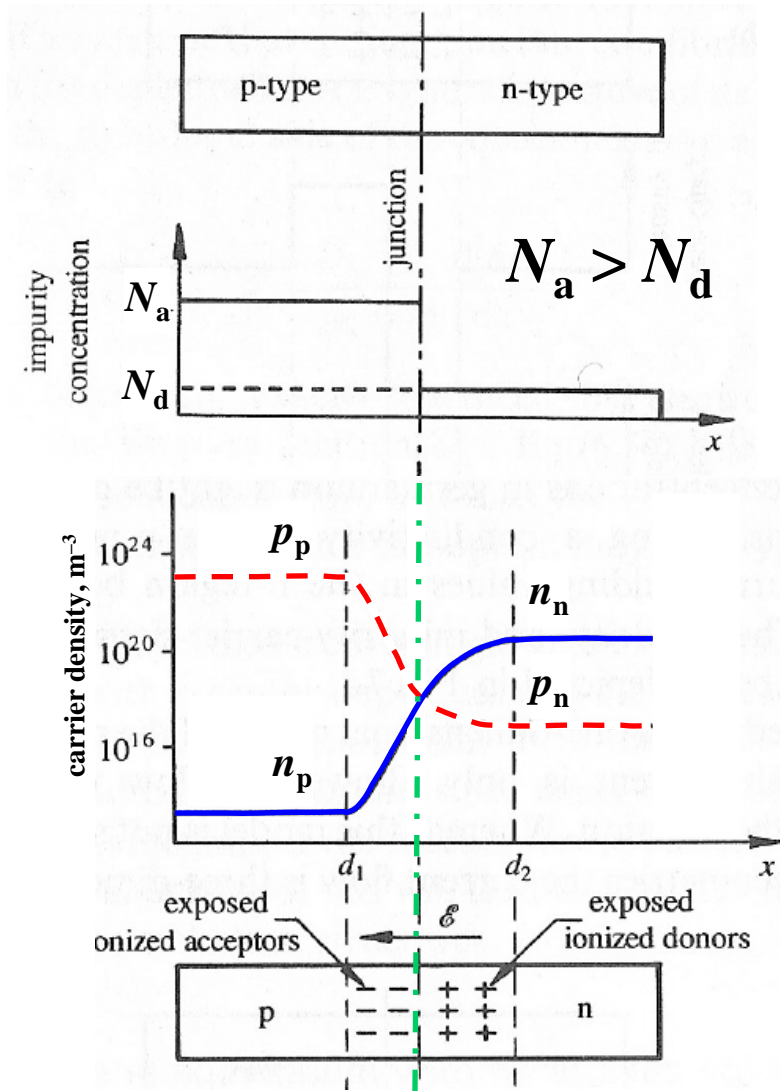
- Consider a pn junction with abrupt transition



Initially, the density of carriers change abruptly at the junction.

Pn junction in equilibrium

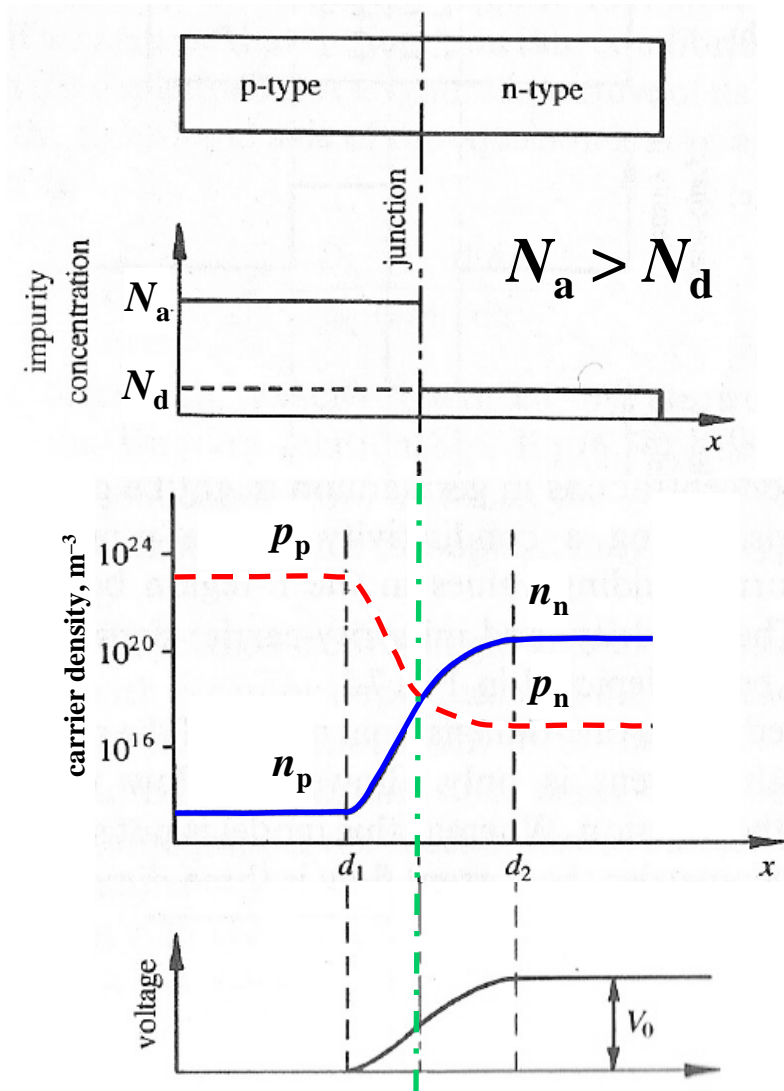
- Consider a pn junction with abrupt transition



This change of concentration causes diffusion which is stopped by exposition of ionized impurities at the transition (called depletion layer $\sim 1\mu\text{m}$).

Pn junction in equilibrium

- Consider a pn junction with abrupt transition



This change of concentration causes diffusion which is stopped by exposition of ionized impurities at the transition (called depletion layer $\sim 1\mu\text{m}$).

In equilibrium, a voltage difference is created across the depletion layer.

Pn junction in equilibrium

- Voltage across the depletion layer
 - Start with continuity eq. for holes

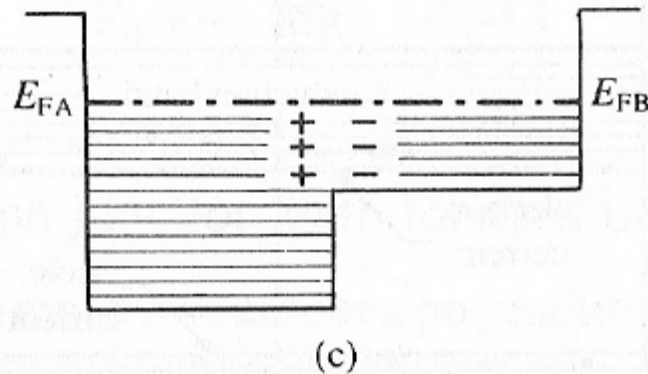
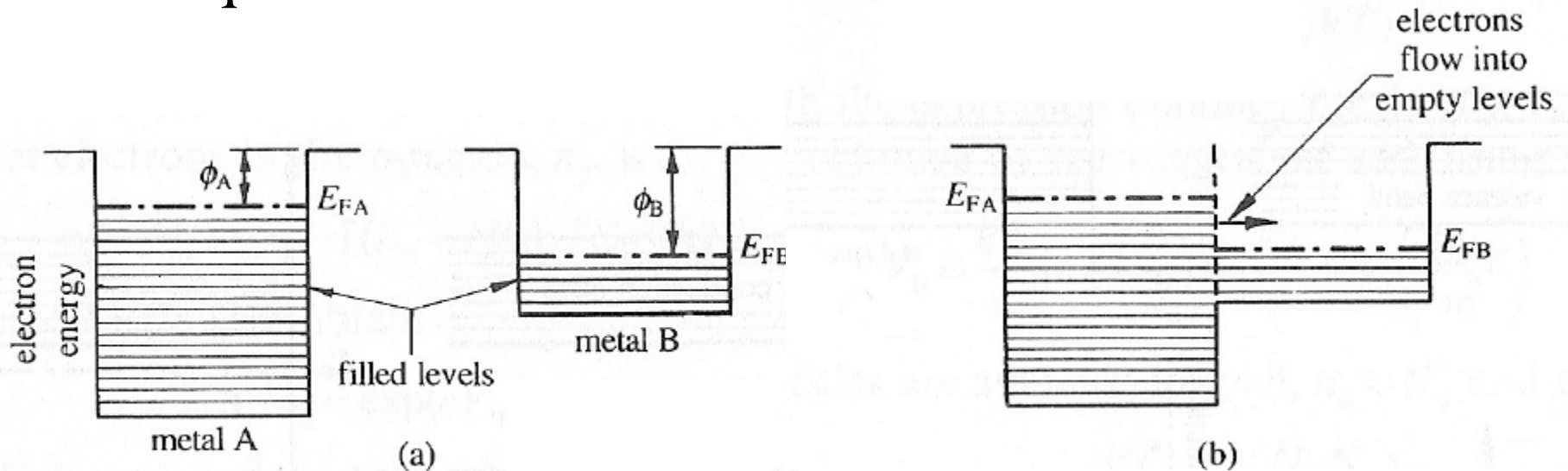
$$\begin{aligned}
 \cancel{\frac{\partial(\delta p)}{\partial t}} &= -\cancel{\frac{\delta p}{\tau_{Lh}}} + \mu_h \mathcal{E}_x \frac{\partial(\delta p)}{\partial x} + D_h \frac{\partial^2(\delta p)}{\partial x^2} \quad \Rightarrow \quad \mathcal{E}_x = \frac{D_h}{\mu_h} \frac{1}{(\delta p)} \frac{d(\delta p)}{dx} \\
 D_h/\mu_h &= kT/e \quad \Rightarrow \quad \mathcal{E}_x = \frac{kT}{e} \frac{1}{(\delta p)} \frac{d(\delta p)}{dx} \quad \Rightarrow \quad e \int_{d_1}^{d_2} \mathcal{E}_x dx = -kT \int_{p_0}^{p_n} \frac{d(\delta p)}{\delta p} \\
 &\quad \Rightarrow \quad \boxed{p_p = p_n \exp(eV_0/kT)}
 \end{aligned}$$

- Idem for electrons

$$\boxed{n_n = n_p \exp(eV_0/kT)}$$

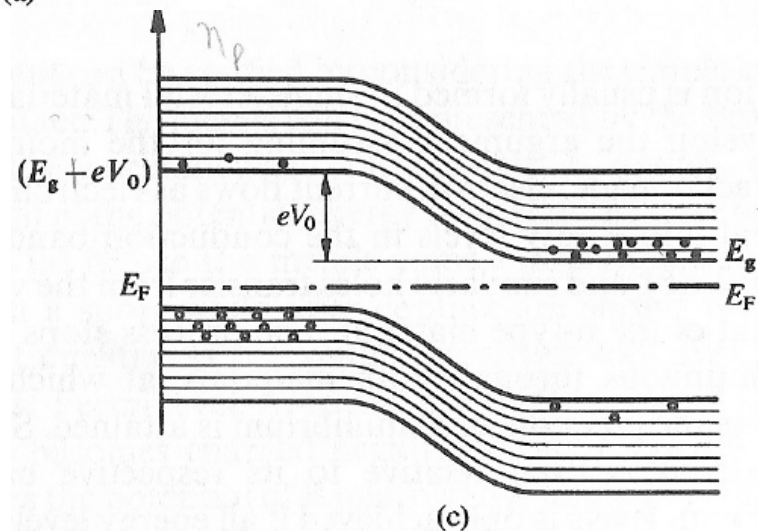
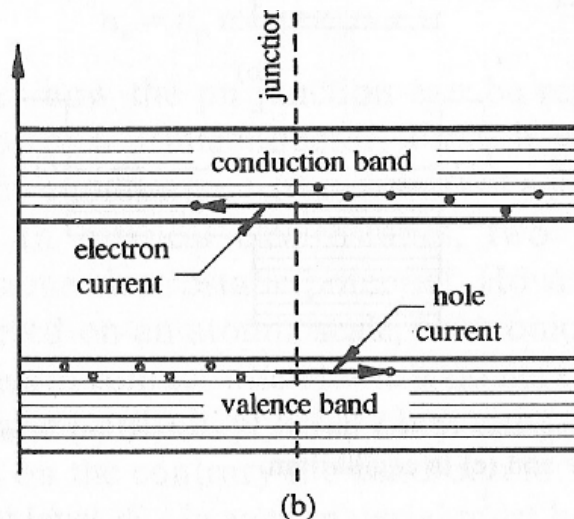
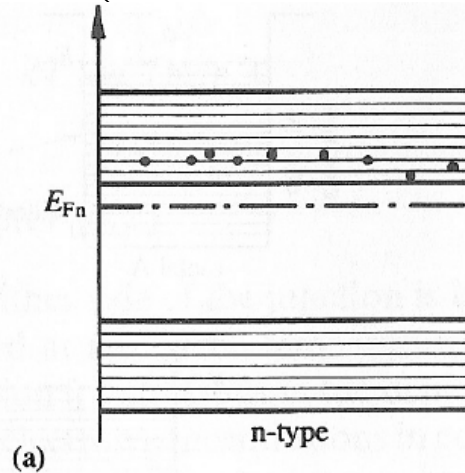
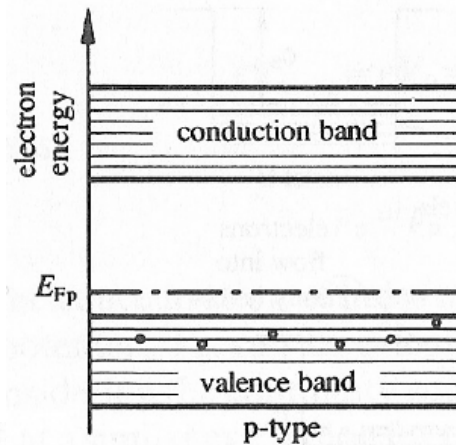
Pn junction in equilibrium

- Junctions and band structure
 - Equilibrium at atomic scale (in metals):



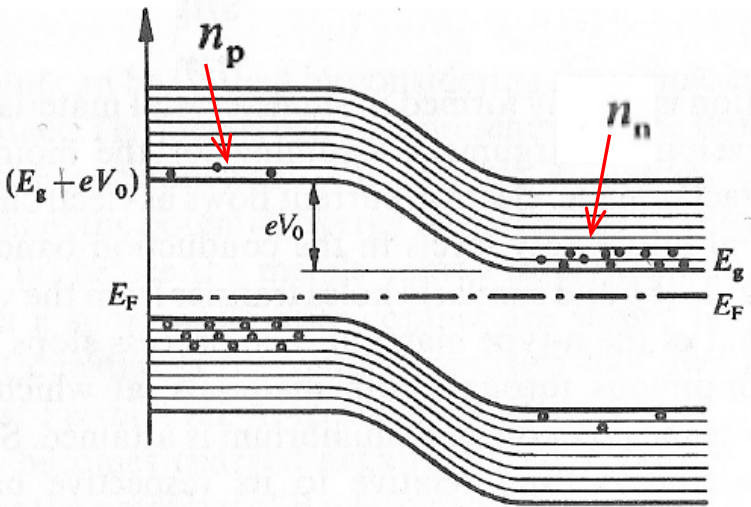
Pn junction in equilibrium

- Junctions and band structure
 - Equilibrium at atomic scale (in semiconductors)



Pn junction in equilibrium

- Number of electrons in the conduction band



$$n_n = N_c \exp[-(E_g - E_F)/kT]$$

$$n_p = N_c \exp\{ -[(E_g + eV_0) - E_F]/kT \}$$

$$\longrightarrow n_n/n_p = \exp(eV_0/kT)$$

- If all the impurities are ionized ($n_n \approx N_d$ and $p_p \approx N_a$):

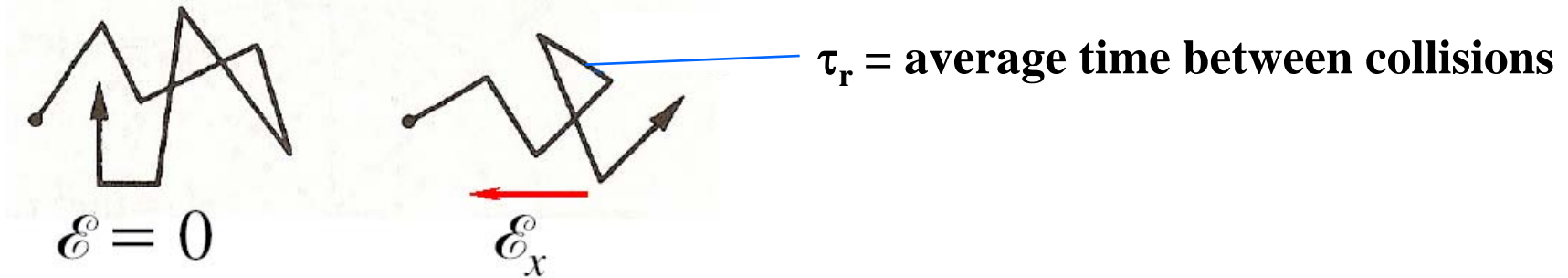
$$V_0 \simeq \frac{kT}{e} \log_e \left(\frac{N_d N_a}{n_i^2} \right)$$

Conclusions

- Extrinsic sC are created by adding impurities:
 - Donors (extra electrons) and acceptors (extra holes).
- Electron processes in sC were qualitatively studied.
- Components of the total current were studied.
- We have deduced the continuity equation for MINORITY carriers.
- Several measurements in sC were studied.
- The junction diode in equilibrium was studied.

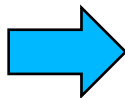
Conduction Processes in a Metal

- Consider a (classical) free e^- moving in a metal.
 - There are collisions with the crystal structure:

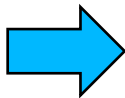


- The friction is assumed to be proportional to $m \dot{x} / \tau_r$:

$$-e\mathcal{E}_x - \frac{m}{\tau_r} \dot{x} = m\ddot{x}$$



$$-e\mathcal{E}_x = m \frac{d}{dt}(v_{Dx}) + \frac{m(v_{Dx})}{\tau_r}$$



$$v_{Dx} = \frac{-e\tau_r \mathcal{E}_x}{m} [1 - \exp(-t/\tau_r)]$$

- At large times ($t \gg \tau_r$): $v_{Dx} = -\frac{eE\tau_r}{m} = \frac{F\tau_r}{m}$